

Notice of References Cited	Application/Control No. 10/057,479	Applicant(s)/Patent Under Reexamination WEBSTER ET AL.	
	Examiner Chrystine Pham	Art Unit 2122	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,536,017	03-2003	Sanders, Lester S.	716/3
	B	US-5,909,689	06-1999	Van Ryzin, John M.	707/203
	C	US-6,381,741	04-2002	Shaw, Robert	717/168
	D	US-6,519,767	02-2003	Carter et al.	717/140
	E	US-5,793,982	08-1998	Shrader et al.	709/232
	F	US-5,892,683	04-1999	Sung, Chiakang	703/27
	G	US-5,948,101	09-1999	David et al.	713/2
	H	US-6,094,702	07-2000	Williams et al.	711/101
	I	US-6,418,554	07-2002	Delo et al.	717/174
	J	US-6,263,497	07-2001	Maeda et al.	717/170
	K	US-6,279,153	08-2001	Bi et al.	717/171
	L	US-6,356,934	03-2002	Delph, Daniel C.	709/204
	M	US-6,381,742	04-2002	Forbes et al.	717/176

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
X	N	KR 2001000362 A	01-2001	Korea, Republic	HAN, S W	G06F 17/60
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.